IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants :

Cox et al.

Serial No.

To be assigned

Filed

Herewith

For

A METHOD OF FORMING A DECORATIVE STRUCTURE

AND A DECORATIVE STRUCTURE MADE BY THE

METHOD

Customer No.:

21003

INFORMATION DISCLOSURE STATEMENT

EXPRESS MAIL NO.: ER589232466US

Mail Stop PATENT APPLICATION Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants bring to the Examiner's attention and enclose herewith the prior art, which are listed on the attached Form PTO 1449. Copies of the cited references are enclosed. It is respectfully requested that the listed prior art be made of record in the application.

The Commissioner is hereby authorized to charge payment of any additional fee or credit any overpayment to Deposit Account No. 02-4377.

Dated: February 6, 2004

Rochelle K. Seide, Ph.D.

Respectfully submitted,

Patent Office Reg. No. 32,300

BAKER BOTTS L.L.P. 30 Rockefeller Plaza

New York, NY 10112-4498

Attorney for Applicants (212) 408-2500

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Form PTO-1449 U.S. Department of Commerce (REV. 2-82) Patent and Trademark Office										Atty. Docket No. A36168 – 072035.0138		Serial No. Not Yet Assigned			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT									MENT	Applicants Cox et al.					
(Use several sheets if necessary)										Filing Date February 6, 2004		up Art Unit Yet Assign			
									U.S. PATE	NT DOCUMENTS					
*Exam. Init.		Document No. Date								Name	Class	Subclass	Filing Date if Appropriate		
		5	7	8	3	2	6	4	07/21/98	Howes	428	13			
		4	3	4	4	9	0	6	08/17/82	Kitagawa et al.	264	128			
		3	9	6	8	0	7	3	07/06/76	Hara et al.	260	42.18			
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Date Considered

Examiner

NY02:474580.1

^{*} Examiner: Initial citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicant.